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Bib Data Sheet

<b>SERIAL NUMBER</b> 10/021,719	<b>FILING OR 371(c) DATE</b> 12/19/2001 <b>RULE</b>	<b>CLASS</b> 372	<b>GROUP ART UNIT</b> 2881	<b>ATTORNEY DOCKET NO.</b> 0756-2409	
<b>APPLICANTS</b> Koichiro Tanaka, Atsugi-shi, JAPAN; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-399462 12/27/2000 <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 01/22/2002</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 25	<b>TOTAL CLAIMS</b> 66	<b>INDEPENDENT CLAIMS</b> 8
<b>ADDRESS</b> 31780					
<b>TITLE</b> Laser annealing method and semiconductor device fabricating method					
<b>FILING FEE RECEIVED</b> 1988	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		